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IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Nobushige KORENAGA et al.) : Examiner: Unassigned
Application No.: 10/777,196) : Group Art Unit: 2834
Filed: February 13, 2004) : Confirmation No.: 5774
For: LINEAR MOTOR, MOVING STAGE SYSTEM,) July 7, 2004
EXPOSURE APPARATUS, AND DEVICE :
MANUFACTURING METHOD)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION OF PRIORITY DOCUMENT


Sir:

In support of Applicants' claim for priority under 35 U.S.C. § 119, enclosed is one certified copy of the following foreign application:

JAPAN 2003-035268, filed February 13, 2003.

Applicants' undersigned attorney may be reached in our Washington, D.C., office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,


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